## JUL 1 7 2007

## **AMENDMENTS TO THE CLAIMS**

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1. (Withdrawn)	
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20. (Currently amended) A process for coating of substrates comprising: inserting a substrate into a process chamber; dehydrating said substrate; supplying a first chemical to a heated vaporization chamber; vaporizing said first chemical; and supplying the vapor of said first chemical to a process chamber, thereby coating said substrate with said first chemical.
21. (Original) The process of claim 20 further wherein said supplying a first chemical comprises withdrawing said first chemical from a first chemical reservoir.
22. (Original) The process of claim 21 wherein said withdrawing said first chemical comprises withdrawing a specific volume of said first chemical from said first chemical reservoir.

- 23. (Original) The process of claim 21, wherein said first chemical reservoir is a chemical manufacturer's source bottle.
- 24. (Cancelled)
- 25. (Currently amended) The process of claim 20 24, wherein said dehydrating a substrate comprises: inserting said substrate into said process chamber; evacuating said chamber to a first pressure; inputting a first gas into said process chamber.
- 26. (Original) The process of claim 25 wherein said first gas is an inert gas.
- 27. (Original) The process of claim 26 wherein said inert gas is nitrogen.
- 28. (Original) The process of claim 25 wherein said first gas is heated.
- 29. (Original) The process of claim 25 further comprising re-evacuating said process chamber subsequent to said inputting a first gas into said process chamber.
- 30. (Original) The process of claim 29 wherein said re-evacuating said process chamber evacuates said process chamber to a second pressure.
- 31. (Original) The process of claim 30 wherein said second pressure is lower than said first pressure.

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32. (Original) The process of claim 20 further comprising:
supplying a second chemical to a heated vaporization chamber;
vaporizing said second chemical; and

supplying the vapor of said second chemical to said process chamber.

- 33. (Original) The process of claim 20 wherein said vaporizing said first chemical occurs in a first vaporization chamber.
- 34. (Original) The process of claim 33 wherein said vaporizing said first chemical comprises heating said first chemical.
- 35. (Original) The process of claim 33 wherein said vaporizing said first chemical comprises exposing said first chemical to reduced pressure.
- 36. (Original) The process of claim 34 wherein said vaporizing said first chemical further comprises exposing said first chemical to reduced pressure.
- 37. (Original) The process of claim 32 wherein said vaporizing said first chemical occurs in a first vaporization chamber.
- 38. (Original) The process of claim 37 wherein said vaporizing said second chemical occurs in said first vaporization chamber.
- 39. (Original) The process of claim 38 wherein said vaporizing said first chemical and said vaporizing said second chemical occur relatively simultaneously.
- 40. (Previously amended) A process for the coating of a substrate comprising:
   inserting a substrate into a process chamber;
   dehydrating said substrate;
   delivering a first amount of a first chemical to a vaporization chamber;

vaporizing said first chemical; and

delivering the vaporized first chemical into said process chamber, thereby coating said substrate with said first chemical.

- 41. (Original) The process of claim 40, wherein said substrate comprises glass.
- 42. (Original) The process of claim 40, wherein said first chemical comprises silane.
- 43. (Original) The process of claim 42 wherein said silane is an amino silane.
- 44. (Original) The process of claim 42 wherein said silane is an epoxy silane.
- 45. (Original) The process of claim 42 wherein said silane is a mercapto silane.
- 46. (Original) The process of claim 40 wherein said delivering a first amount of a first chemical to a vaporization chamber comprises:
  - withdrawing a first amount of a first chemical from a first chemical reservoir; and delivering said first amount of a first chemical to said vaporization chamber.
- 47. (Original) The process of claim 46 wherein said chemical reservoir is a chemical source bottle.
- 48. (Original) The process of claim 46 further comprising replacing the lost volume of chemical in the first chemical reservoir with an inert gas.
- 49. (Original) The process of claim 48 wherein said inert gas is nitrogen.

50. (Original) The process of claim 46 wherein said withdrawing a first amount of a first chemical comprises withdrawing said first amount using a syringe pump.